


<b>Search Notes</b>  	<b>Application/Control No.</b>  10578029	<b>Applicant(s)/Patent Under Reexamination</b>  KIM ET AL.
	<b>Examiner</b>  PAISLEY L ARENDT	<b>Art Unit</b>  2881

SEARCHED			
Class	Subclass	Date	Examiner
349	49-53 (Limited Search)	3/3/2008	PLA
349	50, 51	1/2/2009	PLA
349	50, 51, 48, 114 (limited search)	4/20/2009	PLA

SEARCH NOTES			
Search Notes		Date	Examiner
See attached Search History.		3/3/2008	PLA
See attached search history.		1/2/2009	PLA
See attached search history.		4/20/2009	PLA

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
	See attached search history.	4/20/2009	PLA

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